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OFGS File No: P/2699-30

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
YOKOUCHI, Kenichi et al

New York, New York  
Date: February 23, 2005

Serial No.: 10/645,065

Group Art Unit: 1763

Date Filed: August 21, 2003

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING  
METHOD

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U. S. Patent and Trademark Office on August 21, 2003.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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